

February 9, 2004

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MAIL STOP PATENT APPLICATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Re:

Application of Naohiro KAMIYA

METHOD OF MANUFACTURING A GLASS SUBSTRATE FOR A

MAGNETIC DISK AND METHOD OF MANUFACTURING A MAGNETIC

DISK

Assignee: HOYA CORPORATION

Our Ref. Q79783

Dear Sir:

Attached hereto is the application identified above comprising twenty-two (22) sheets of the specification, including the claims and abstract (in Japanese Language) and one (1) sheet of drawings. Copies of the executed Declaration and Power of Attorney and Assignment and an English language translation of the Application will be submitted at a later date.

The Government filing fee is calculated as follows:

Total claims	5 - 20	=	X	\$18.00	= '	\$.00
Independent claims	1 - 3	=	x	\$86.00	=	\$.00
Base Fee						\$770.00

TOTAL FEE ______\$770.00

A check for the statutory filing fee of \$770.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this transmittal letter is attached.



Attorney Docket No: Q79783 Filing Date: February 9, 2004

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Priority is claimed from:

Country

Application No

Filing Date

JAPAN

2003-31630

February 7, 2003

The priority document will be filed at a later date. Since the anniversary of the filing of the first priority document fell on Saturday, February 7, 2004, the filing of this Application on Monday, February 9, 2004 is sufficient to claim the benefit of all priority documents.

Respectfully submitted, SUGHRUE MION, PLLC

Attorneys for Applicant

Bv

Alan J. Kasper

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